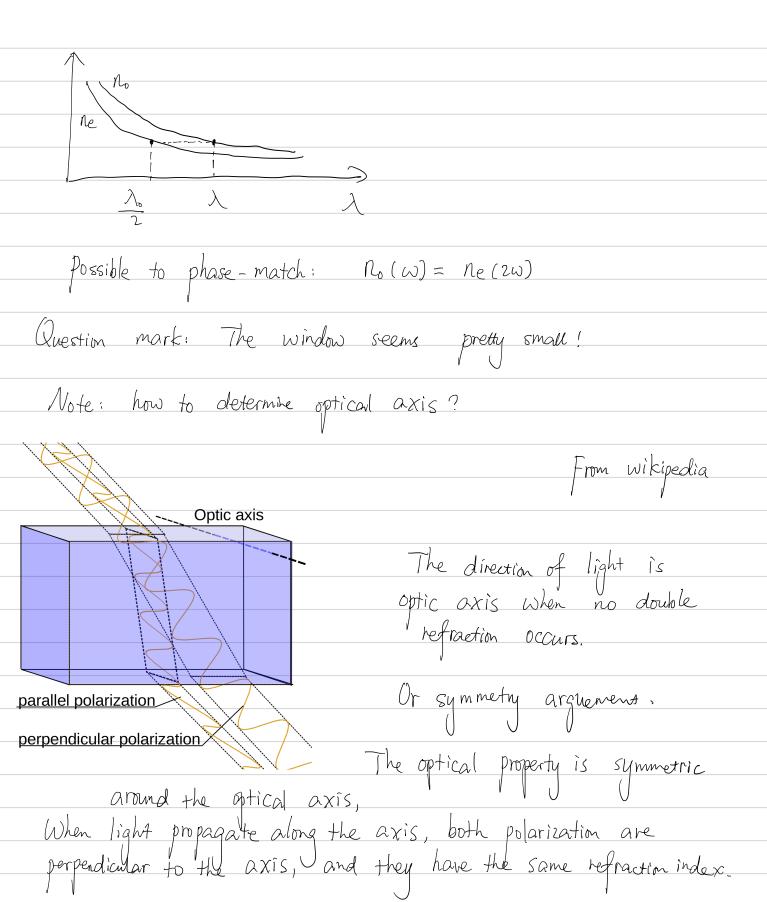
Methods of phase matching Dispersion. Most of the materials have normal dispersion at visible and near-infred wavelength. So it's impossible to directly satisfy N(w) = N(2w)Method 1: Birefringent crystal:

ordinary wave wave.

(perpendiculary to the plane

formed by E and optical lattice)

T is the optical axis for the crystal material



How to phase match? $\frac{1}{N_e^2(0)} = \frac{\sin^2\theta}{N_e^2} + \frac{\cos^2\theta}{N_o^2},$ The is the ne at 0=90°. I along the E axis. So the extraordinary refractive index can be tured from N_0 (0=0°) to Ne(0=90°)ordinary wave wave wave So rotate the crystal to find the phase matching angle. Normally, vendor will mark the optical axis for you. Note: why the rule of new) is in a square form? VE - Er vE = 0 (linear case); Er=Nr. This is called "Angle phase match"

Drawback: Direction of phase propagation R is different from energy propagation: for extra-ordinary wave.



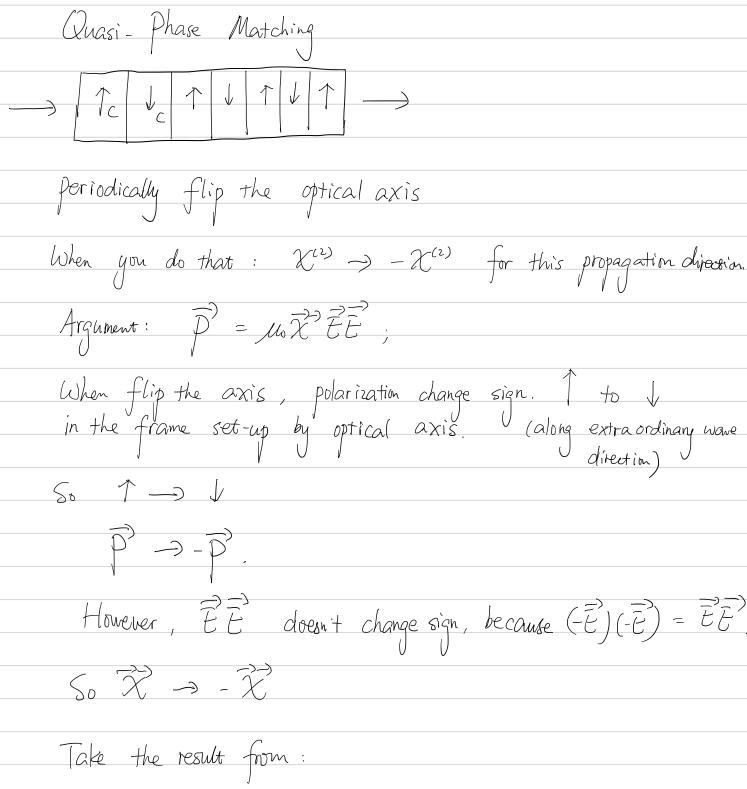
The angle between R and S (Poynting vector) is:

 $\Delta\theta = -1$ $\partial\theta$ (milliradian range)

Cause? extra-ordinary wave has components along 2 and perpendicular to 2.

So when calculate $\vec{S} = \vec{E} \times \vec{H}$; not always back to \vec{K} direction. Limit the interaction range.

Phase-matching can also be slightly tuned by temperature.



$$\frac{2i \omega \mathcal{E}_0 \omega^2 x^2 L_1^2 (z=0)}{8z} = \frac{2i \omega \mathcal{E}_0 \omega^2 x^2 L_1^2 (z=0)}{2}$$

$$E_{x}(z=L) = \int \frac{2j4n\xi_{0}\omega^{2}X^{(1)}}{k_{z}} E_{z}^{2}(0) e^{i(zk_{z}-k_{z})z} \sim \int iX^{(1)}E_{z}^{2}e^{j(zk_{z}-k_{z})z},$$

$$Now: \det \left\{ \begin{array}{c} X^{(2)} = d, & \text{when } 2N/2 < (2k_{z}-k_{z})z < (2N+1)Z, \\ X^{(2)} = -d, & \text{when } (2N+1)Z < (2k_{z}-k_{z})z < (2N+2)Z, \\ Why? Because previously, the intergral from 0-32 was canteled by 2-32.

So if flip the sign of 2-322, we get enhanced result, instead of cancellation.

at $2N_{z} < (2k_{z}-k_{z})z < (2N+1)Z$.

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = \frac{d_{z}-E_{z}^{2}}{(2k_{z}-k_{z})}(e^{j2}-e^{j0}) = -2d_{z}-2d_{z}^{2}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -2d_{z}^{2}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -2d_{z}^{2}E_{z}^{2}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -2d_{z}^{2}E_{z}^{2}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -2d_{z}^{2}E_{z}^{2}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -2d_{z}^{2}E_{z}^{2}e^{j(zk_{z}-k_{z})z}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}(e^{j2}-e^{j2}) = -dE_{z}^{2}e^{j(zk_{z}-k_{z})z}$$

$$\int_{2k_{z}-k_{z}}^{2k_{z}+k_{z}} X^{(2)}E_{z}^{2}e^{j(zk_{z}-k_{z})z} dz = -dE_{z}^{2}e^{j(zk_{z}-k_{z})z} + dE_{z}^{2}e^{j(zk_{z}-k_{z})z} + dE_{z}^{2}e^{j(zk_{z}-k_{z})z} + dE_{z}^{2}e^{j(zk$$$$

Fabrication method:

Use high static voltage to invert the orientation of ferroelectrical domain, and therefore \overline{C} axis.

Voltage around 20 kV/mm.

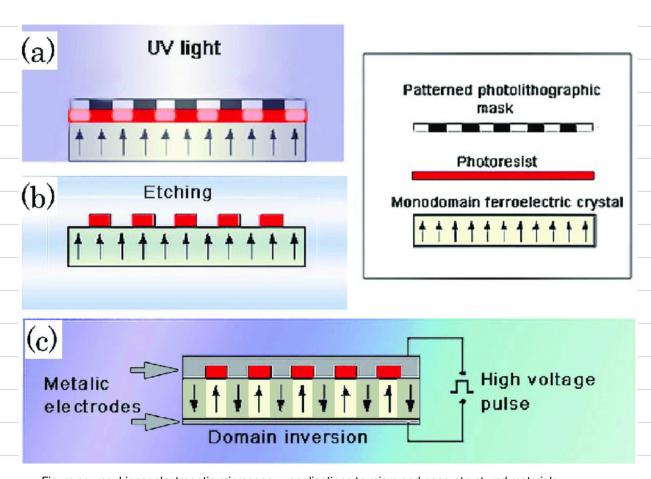


Figure source: Linear electrooptic microscopy: applications to micro and nano-structured materials